Explosion Proof Pressure Transmitter

Model: P119P129 (Explosion Proof Head)



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Advantages

Explosion Proof transmitter for industrial applications

- Extremely corrosion resistant
- · Rugged piezoresistive measuring cell
- · Shock and vibration resistant
- · Zero and span adjustments
- Optimal accuracy
- Measuring ranges
- Ceramic sensor : 0.5 ~ 500 bar
 Silicon sensor : 0.1 ~ 350 bar
- Silicon high pressure sensor : 400 ~ 1000 bar



The transmitters can be used for a wide range of applications in process control, automatic machinery and hydraulic or pneumatic system design.

- Standard hydraulic and pneumatic equipments
- Process control
- · Machine tools and automatic machinery
- Monitoring systems
- Servo valves and drives
- Chemical and petrochemical industry
- Air and gas compressors
- · Loading and brake systems



P119P129

Certificate

Ex d IIC T6 (IP65)

Descriptions

P119P129 series pressure transmitter has been designed as an advanced device for measuring pressure of gases and liquids in industrial applications. It is extremely versatile and suitable for measuring static pressure. The built-in measuring ceramic or silicon cell is highly corrosion resistant, stable and has an excellent price / performance ratio. Thanks to their high natural frequency and the rugged construction, the P119p129 transmitter withstands high shock and vibration. The transmitters are available as absolute and relative pressure types with either 2-wire current or 3-wire voltage output.

The pressure to be measured acts without transmitting liquid fill on a stable, corrosion resistant ceramic or silicon measuring cell. Piezoresistive resistors are attached to the cell and connected in a Wheatstone bridge configuration. The output signal of this bridge is converted into a standardized current or voltage output signal.

Specification

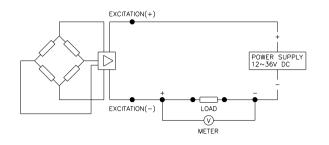
Technology	!					
Pressure ranges Ceramic sensor : 0~0.5 to 0~500bar absolute or gauge pressure Silicon sensor : 0~0.1 to 0~350bar absolute or gauge pressure High pressure Silicon sensor : 0~400 to 0~1000bar absolute or gauge pressure Pressure reference Gauge, absolute, vacuum and compound Ceramic sensor : 1.5x full scale without damage Silicon sensor : 3x full scale without damage High pressure Silicon sensor : 3x full scale without damage Output Unamplified Unamplified Electrical connection type 2-wire technique Full scale output signal Zero measured output 4mA ±0.05% 1V ±0.05 Other signals available on request						
Silicon sensor : 0~0.1 to 0~350bar absolute or gauge pressure High pressure Silicon sensor : 0~400 to 0~1000bar absolute or gauge pressure Pressure reference Gauge, absolute, vacuum and compound Overload Ceramic sensor : 1.5x full scale without damage Silicon sensor : 3x full scale without damage High pressure Silicon sensor : 3x full scale without damage Output Unamplified Unamplified Electrical connection type 2-wire technique 3 or 4-wire technique Full scale output signal 20mA ±0.5% Zero measured output 4mA ±0.05% 1V ±0.05 Other signals available on request						
High pressure Silicon sensor : 0~400 to 0~1000bar absolute or gauge pressure Pressure reference Gauge, absolute, vacuum and compound Overload Ceramic sensor : 1.5x full scale without damage Silicon sensor : 3x full scale without damage High pressure Silicon sensor : 3x full scale without damage Output Unamplified Unamplified Electrical connection type 2-wire technique Full scale output signal 20mA ±0.5% 5V ±0.5% Zero measured output 4mA ±0.05% 1V ±0.05 Other signals available on request						
Pressure reference Overload Ceramic sensor : 1.5x full scale without damage Silicon sensor : 3x full scale without damage High pressure Silicon sensor : 3x full scale without damage Output Unamplified Unamplified Electrical connection type Full scale output signal Zero measured output Gauge, absolute, vacuum and compound Ceramic sensor : 1.5x full scale without damage High pressure Silicon sensor : 3x full scale without damage Unamplified Unamplified 2-wire technique 3 or 4-wire technique Full scale output signal AmA ±0.5% Other signals available on request						
Overload Ceramic sensor : 1.5x full scale without damage Silicon sensor : 3x full scale without damage High pressure Silicon sensor : 3x full scale without damage Output Unamplified Unamplified Electrical connection type Full scale output signal Zero measured output 4mA ±0.05% Other signals available on request						
Silicon sensor : 3x full scale without damage High pressure Silicon sensor : 3x full scale without damage Output Unamplified Unamplified Electrical connection type 2-wire technique 3 or 4-wire technique Full scale output signal 20mA ±0.5% 5V ±0.5% Zero measured output 4mA ±0.05% 1V ±0.05% Other signals available on request						
High pressure Silicon sensor : 3x full scale without damage Output Unamplified Unamplified Electrical connection type 2-wire technique Full scale output signal 20mA ±0.5% 5V ±0.5% Zero measured output 4mA ±0.05% 1V ±0.05% Other signals available on request						
Output Unamplified Unamplified Electrical connection type 2-wire technique 3 or 4-wire technique Full scale output signal $20mA$ $\pm 0.5\%$ $5V$ $\pm 0.5\%$ Zero measured output $4mA$ $\pm 0.05\%$ $1V$ $\pm 0.05\%$ Other signals available on request						
UnamplifiedUnamplifiedElectrical connection type2-wire technique3 or 4-wire techniqueFull scale output signal $20mA$ $\pm 0.5\%$ $5V$ $\pm 0.5\%$ Zero measured output $4mA$ $\pm 0.05\%$ $1V$ $\pm 0.05\%$ Other signals available on request						
Electrical connection type2-wire technique3 or 4-wire techniqueFull scale output signal $20mA$ $\pm 0.5\%$ $5V$ $\pm 0.5\%$ Zero measured output $4mA$ $\pm 0.05\%$ $1V$ $\pm 0.05\%$ Other signals available on request						
Full scale output signal 20mA $\pm 0.5\%$ 5V $\pm 0.5\%$ Zero measured output 4mA $\pm 0.05\%$ 1V $\pm 0.05\%$ Other signals available on request						
Zero measured output $4mA$ $\pm 0.05\%$ $1V$ ± 0.05 Other signals available on request						
Other signals available on request	, 0					
	%					
Electrical Specification						
ceramic cell silicon cell High pressure s	ilicon cell					
Excitation voltage 24V DC (12~36V DC)						
Load resistance max @ 24V 500 Ω at 24V						
Influence of excitation 0.01% FSO/V						
Power ripple ≤500mV P-P						
Reverse polarity Protected						
Shock resistance ≤20g No change in performance after 110Gs for 11	me					
Vibration 0.1G (1m/s/s) maximum	1113					
Response time(10~90%) 1.5ms ≤2 milliseconds						
Adjustment ±10% FSO/zero and span						
Performance Specification						
	≤±0.5% FSO					
Linearity, Hysteresis & Repeatability ±0.2% FSO typical ±0.125% FSO typical ±0.320% FSO t						
Stability ±0.3% FSO/a @25°C ±0.3% FSO over 6 month ±0.1% FSO over	er 6 month					
Cutoff frequency(-3 d B) \leq 2kHz						
Reference temperature 25°C 35°C						
Operating temperature range -40~125°C						
Compensated temperature range 0~70°C 0~82°C -20~82°C	-20~82°C					
Thermal sensitivity shift $\leq \pm 0.015\%$ °C typical $\leq \pm 0.2\%$ FSO in reference to 35°C typical	35°C typical					
Thermal zero shift $\leq \pm 0.02\%$ FSO/°C typical $\leq \pm 0.2\%$ FSO in reference to 35°C typical						
	≤±0.1% FSO in reference to 35°C typical					
Physical Specification						
ceramic cell silicon cell & High pressure sili	con cell					
Process connection PT1/4 , PT3/8 , PT1/2 male thread						
PF1/4 , PF3/8 , PF1/2 male thread						
Female thread & other connections available on request						
	Gases and liquids compatible with ceramic Gases and liquids compatible with					
, , ,						
N2 O3 06% Stainlage stool 3161	2461					
Al2 O3, 96% Stainless steel 316L	T Diaphiragin . Stairliess Steel 3 10L					
Materials wetted by process Diaphragm : Ceramic Al2 O3, 96% Diaphragm : Stainless steel	0 10L					
Materials wetted by process Diaphragm: Ceramic Al2 O3, 96% Diaphragm: Stainless steel Housing: Stainless steel 316	V 10L					
Materials wetted by process Diaphragm: Ceramic Al2 O3, 96% Housing: Stainless steel 316 Gasket O-ring: Viton (HNBR, CSM, etc.)						
Materials wetted by process Diaphragm: Ceramic Al2 O3, 96% Housing: Stainless steel 316 Gasket O-ring: Viton (HNBR, CSM, etc.) Enclosure rating Diaphragm: Stainless steel 316 Gasket O-ring: Viton (HNBR, CSM, etc.)	U10L					
Materials wetted by process Diaphragm : Ceramic Al2 O3, 96% Housing : Stainless steel 316 Gasket O-ring : Viton (HNBR, CSM, etc.) Enclosure rating Explosion protection Diaphragm : Stainless steel 316 Gasket O-ring : Viton (HNBR, CSM, etc.) Explosion protection Ex d IIC T6	0102					
Materials wetted by process Diaphragm : Ceramic Al2 O3, 96% Housing : Stainless steel 316 Gasket O-ring : Viton (HNBR, CSM, etc.) Enclosure rating Explosion protection Ex d IIC T6 Influence of mounting position Diaphragm : Stainless steel Housing : Viton (HNBR, CSM, etc.) Influence of mounting position Not critical						
Materials wetted by process Diaphragm : Ceramic Al2 O3, 96% Housing : Stainless steel 316 Gasket O-ring : Viton (HNBR, CSM, etc.) Enclosure rating IP65 Explosion protection Influence of mounting position Weight Diaphragm : Stainless steel Housing : Viton (HNBR, CSM, etc.) Influence of mounting position Not critical Approx. (560g)						
Materials wetted by process Diaphragm : Ceramic Al2 O3, 96% Housing : Stainless steel 316 Gasket O-ring : Viton (HNBR, CSM, etc.) Enclosure rating Explosion protection Ex d IIC T6 Influence of mounting position Diaphragm : Stainless steel Housing : Viton (HNBR, CSM, etc.) Influence of mounting position Not critical						

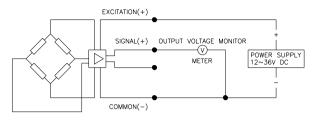
Note: ① Cable version: 1.5m standard length, 4-wire, shielded with integral vent tube

- ② Vented gauge units must breathe dry, non corrosive gases.
- ③ Connector version is vented through the removed pin, cable versions are vented through a vent tube inside

System connection for 2-wire transmitter

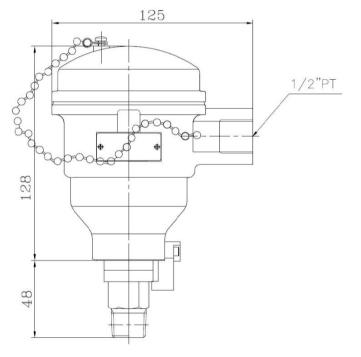
System connection for 3-wire transmitter

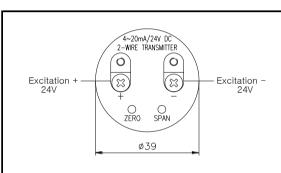




Dimension (mm)

Electrical connection





Ordering Information									
Explosion Proof Pressure Transmitter									
1. Base model	0011			uiio		,,			
P119P129								Explosion Proof Head	
2. Pre	essure	refere	nce						
R								Relative pressure	
Α	L			<u>Ļ</u>	L			Absolute pressure	
<u>.</u>	3. Proc	ess co	nnec	tion t	ype "	1"			
	<u>M</u>	-	_					Male thread	
L	F L	Proce	00.00	<u> </u>	tion t	(DO "	2"	Female thread	
	 4.	- I	35 60	I	lion t	ype	_	PT thread as standard	
			1		1			NPT thread	
	H		1					PF thread	
		(1				Other process connections available on request	
		5. F	roces	ss co	nnec	ion s	ize		
		1						1/4"	
		2						3/8"	
		3						1/2"	
		Χ	Щ.		L.,		L	Other units available on request	
				ccura	acy (S	enso	or typ)e)	
			S					±0.25% F.S.O (with Silicon cell)	
			С		-	-		±0.5% F.S.O (with Ceramic cell)	
			<u>H</u>	7 M	loocu	ring	rang	±0.5% F.S.O (with High pressure silicon cell)	
				01	<u>leasu</u>	nng	ang	= 0 ~ 0.5 bar	
				02	1			0 ~ 1	
				03				0~2	
				04				0~5	
				05				0 ~ 10	
				06				0 ~ 20	
				07				0 ~ 35	
				08				0 ~ 50	
				09				0 ~ 100	
				10				0 ~ 200	
				11				0 ~ 350	
				12	-	-		0 ~ 400 (Only available Ceramic sell & High pressure silicon cell)	
				13				0 ~ 500 (Only available Ceramic sell & High pressure silicon cell) 0 ~ 600 (Only available High pressure silicon cell)	
				14 15	1			0 ~ 600 (Only available High pressure silicon cell) 0 ~ 700 (Only available High pressure silicon cell)	
				16				0 ~ 800 (Only available High pressure silicon cell)	
				17				0 ~ 900 (Only available High pressure silicon cell)	
				18				0 ~ 1000 (Only available High pressure silicon cell)	
				XX				Other calibration ranges available on request	
					8. U	nit		,,	
					K			Calibration in kgf/cm2	
					Α			Calibration in Mpa	
					В			Calibration in bar	
					Р			Calibration in psi	
					Χ		Ļ	Other units available on request	
							utpu	t signal / Electrical connection type	
						A1 A2		4~20mA, DC, 2-wire output	
								4~20mA, DC, 4-wire output	
						B1 B2		1~5V, DC, 3-wire output 1~5V, DC, 4-wire output	
						DΖ	10	Option	
								None options	
							C	Cooling Fin	
							Š		
							X	Other accessories available on request	